

<b>Notice of References Cited</b>	Application/Control No. 10/723,528	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Eliseo Ramos-Feliciano	Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0243942 A1	11-2005	Sawai, Ryo	375/267
*	C	US-2006/0120476 A1	06-2006	Li et al.	375/267
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	K	US-			
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	M	US-			

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**NON-PATENT DOCUMENTS**

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